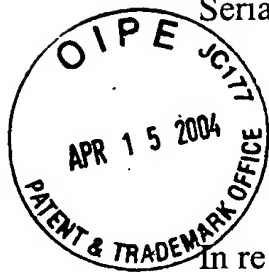


Serial No.: 10/605,167

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Docket No. FIS920030185US

D. Chidambarao et al.

Serial No.: 10/605,167

Group Art Unit: No. 2822

Filed: September 12, 2003

Examiner: Pamela Perkins

For: **MOSFET PERFORMANCE IMPROVEMENT USING
DEFORMATION IN SOI STRUCTURE**

Mail Stop: Non-final amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Restriction Requirement dated April 2, 2004, Applicants elect Group I, claims 1-16, without traverse. Claims 19-20 are canceled.

Applicants believe that no extensions of time or fees for net addition of claims are required at this time. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 23-1951.